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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/697,032	10/31/2003	Dong-Bock Lee	SEC.1043	1092
20987 7	590 02/23/2006		EXAM	INER
VOLENTINE ONE FREEDO	E FRANCOS, & WHITT	ALEJANDRO MULERO, LUZ L		
	OM DRIVE SUITE 1260		ART UNIT	PAPER NUMBER
RESTON, VA			1763	,

DATE MAILED: 02/23/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

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-		Application No.	Applicant(s)			
Office Action Summary		10/697,032	LEE, DONG-BOCK			
		Examiner	Art Unit			
		Luz L. Alejandro	1763			
Period fo	The MAILING DATE of this communication app or Reply	ears on the cover sheet with the c	orrespondence address			
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DANSIONS of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. It is specified above, the maximum statutory period were to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim vill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONEI	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).			
Status						
1)⊠	Responsive to communication(s) filed on O1 D	<u>ecember 2005</u> .				
2a)⊠	This action is FINAL . 2b) ☐ This action is non-final.					
3)	Since this application is in condition for allowar					
	closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.			
Dispositi	ion of Claims					
4)⊠	Claim(s) 1-19 is/are pending in the application.					
	4a) Of the above claim(s) is/are withdraw	wn from consideration.				
5)	Claim(s) is/are allowed.					
• —-	Claim(s) <u>1-19</u> is/are rejected.					
	Claim(s) is/are objected to.	and and the control of the control o				
8)	Claim(s) are subject to restriction and/o	r election requirement.				
Applicat	ion Papers					
9)□	The specification is objected to by the Examine	er.				
10)[The drawing(s) filed on is/are: a) ☐ acc	epted or b) objected to by the	Examiner.			
	Applicant may not request that any objection to the					
_	Replacement drawing sheet(s) including the correct					
11)	The oath or declaration is objected to by the Ex	kaminer. Note the attached Oπice	Action of form P1O-152.			
Priority (under 35 U.S.C. § 119					
а)	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Burea See the attached detailed Office action for a list	s have been received. s have been received in Applicat rity documents have been receive u (PCT Rule 17.2(a)).	ion No ed in this National Stage			
2) Notice 3) Infor	nt(s) ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) er No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:				

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-3, 6, and 9-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hama et al., U.S. Patent 5,792,261 in view of Aruga, U.S. Patent 5,779,848.

Hama et al. shows the invention as claimed including a chamber structure of an inductive coupling plasma etching apparatus (see col. 13-lines 49-56), comprising: an etch chamber 16 in which an etching process is performed; a plasma chamber 18 in which plasma is generated; and a segregation wall part 14 having a portion made of quartz ceramic material opposite to the etch chamber that is a ceiling wall of the etch chamber, and having a portion made of quartz material opposite to the plasma chamber that is a bottom wall of the upper chamber, the segregation wall part separating the etch chamber from the plasma chamber (see fig. 1 and col. 3-line 61 to col. 7-line 23).

Hama et al. is applied as above but fails to expressly disclose the segregation wall part having a portion made of a non-quartz ceramic opposite to the etch chamber and the chamber being of cylindrical shape. Aruga discloses covering a quartz window with an aluminum nitride ceramic in order to protect the window from damage due to plasma (see abstract and fig. 1 and its description). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made

to modify the apparatus of Hama et al. so as to have the portion of the segregation wall part opposite to the etch chamber of a non-quartz ceramic because this will adequately protect the segregation wall part from the plasma.

With respect to the particular shape of the chamber, a prima facie case of obviousness exists because the particular shape of the chamber would not render patentability to the claimed invention absent persuasive evidence that the claimed shape is significant.

Concerning claim 2, note that the plasma chamber is an upper portion of the chamber structure and the etch chamber is the lower portion of the chamber structure.

Claims 4, 7 and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hama et al., U.S. Patent 5,792,261 in view of Aruga, U.S. Patent 5,779,848 as applied to claims 1-3, 6, and 9-11 above, and further in view of Li et al., U.S. Patent 6,009,830.

Hama et al. and Aruga are applied as above but fails to expressly disclose wherein the portion of the segregation wall part opposite to the etch chamber includes a heater that heats the ceramic material. Li et al. discloses an inductively coupled apparatus including a coil 24 and a heating element 28 enclosing the coil so as to heat the chamber surfaces (see fig. 1 and its description). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the apparatus of Hama et al. modified by Aruga so as to include a heater in

the segregation wall part because such a heater will allow better controllability of the process being conducted within the apparatus.

Claims 5, 8, 13-14, 16, and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hama et al., U.S. Patent 5,792,261 in view of Aruga, U.S. Patent 5,779,848 as applied to claims 1-3, 6, and 9-11 above, and further in view of Yin et al., U.S. Patent 6,352,049.

Hama et al. and Aruga are applied as above but do not expressly disclose wherein the segregation wall part includes gas flow paths and gas exhaust holes that supply process gas into the etch chamber.

Yin et al. discloses a segregation wall part 304 including gas flow paths and gas exhaust paths that supply process gas into the etch chamber which is made of ceramic material opposite to the etch chamber, the segregation wall part separating the etch chamber from the plasma chamber (see fig. 6 and its description). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the apparatus of Hama et al. modified by Aruga so as to include the gas flow paths in the segregation wall part as disclosed by Yin et al. because this is a suitable alternative to provide gas flow into the etch chamber.

Concerning claims 14, 16, and 18, note that the apparatus of Hama et al. modified by Aruga and Yin et al. will disclose the claimed limitations.

Claims 15, 17, and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hama et al., U.S. Patent 5,792,261 in view of Aruga, U.S. Patent 5,779,848 and Yin et al., U.S. Patent 6,352,049 as applied to claims 5, 8, 13-14, 16, and 18 above, and further in view of Li et al., U.S. Patent 6,009,830.

Hama et al., Aruga, and Yin et al. are applied as above but fail to expressly disclose wherein the portion of the segregation wall part opposite to the etch chamber includes a heater that heats the ceramic material. Li et al. discloses an inductively coupled apparatus including a coil 24 and a heating element 28 enclosing the coil so as to heat the chamber surfaces (see fig. 1 and its description). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the apparatus of Hama et al. modified by Aruga and Yin et al. so as to include a heater in the segregation wall part because such a heater will allow better controllability of the process being conducted within the apparatus.

Response to Arguments

Applicant's arguments filed 12/1/05 have been fully considered but they are not persuasive.

In response to applicant's argument that there is no suggestion to combine the references, the examiner recognizes that obviousness can only be established by combining or modifying the teachings of the prior art to produce the claimed invention where there is some teaching, suggestion, or motivation to do so found either in the references themselves or in the knowledge generally available to one of ordinary skill in

the art. See *In re Fine*, 837 F.2d 1071, 5 USPQ2d 1596 (Fed. Cir. 1988) and *In re Jones*, 958 F.2d 347, 21 USPQ2d 1941 (Fed. Cir. 1992). In this case, the motivation to combine the Hama et al. and Aruga references is clearly stated above, for example, to protect the quartz from the effects of a corrosive plasma, such as a halogen containing plasma. Concerning the fact that Aruga does not suggest coating a segregation wall separating a plasma generation chamber and process chamber, one cannot show nonobviousness by attacking references individually where the rejections are based on combinations of references. See *In re Keller*, 642 F.2d 413, 208 USPQ 871 (CCPA 1981); *In re Merck & Co.*, 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986). Regarding element 18 of Hama being considered to be a plasma generation chamber, the examiner respectfully submits that fig. 1 of Hama makes clear that considering element 18 to be a plasma generation chamber is proper and therefore the rejection is maintained.

Applicant also argues that Li does not disclose a segregation part separating an etch chamber and a plasma generation chamber including a heater. However, one cannot show nonobviousness by attacking references individually where the rejections are based on combinations of references. See *In re Keller*, 642 F.2d 413, 208 USPQ 871 (CCPA 1981); *In re Merck & Co.*, 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986). Concerning the combination of references used to reject claim 5 and their motivation, suitability for an intended purpose is an adequate motivation to combine references and therefore this rejection is proper.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Luz L. Alejandro whose telephone number is 571-272-1430. The examiner can normally be reached on Monday to Thursday from 7:30 to 6:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571-272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Luz L. Alejandro Primary Examiner Art Unit 1763

February 21, 2006